

Application/Control No.	Applicant(s)/Patent under Reexamination
10/082,449	LI ET AL.
Examiner	Art Unit
John Pezzlo	2662

SEARCHED					
Class	Subclass	Date	Examiner		
370	427, 7 369,				
	375	10/7/05	DP		
	380 ( 419	11			
	419				
	411				

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
370	427,7		. (		
	419 6	10/7/05	H.		
	411)				
	:	·			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
_	DATE	EXMR		
refer to EAST. Sloveh	N/7/05	JP.		
	_			